



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 27, 2026

IGI Report Number

LG830677633

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE MODIFIED BRILLIANT

Measurements

9.68 X 5.36 X 3.17 MM

GRADING RESULTS

Carat Weight

1.10 CARAT

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

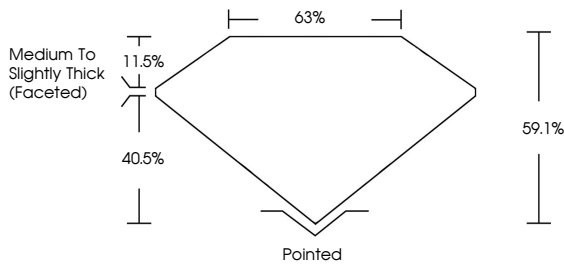
Inscription(s)

 LG830677633

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

Report verification at igi.org

PROPORTIONS



Medium To Slightly Thick (Faceted)

63%

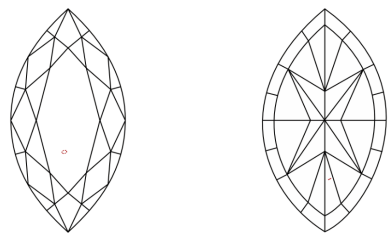
11.5%

40.5%

59.1%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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Depth

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Girdle

63%

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Culet

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